



Attorney's Docket No. 5649-1286

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Ki-yeon Park et al.
Application No.: 10/828,596
Filed: April 21, 2004

Confirmation No.: 5520
Group Art Unit: 2813
Examiner: Laura M. Schillinger

For: METHODS OF FORMING METAL THIN FILMS, LANTHANUM OXIDE FILMS, AND
HIGH DIELECTRIC FILMS FOR SEMICONDUCTOR DEVICES USING ATOMIC
LAYER DEPOSITION

September 14, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a Supplemental Form PTO-1449 listing documents cited in a Notice to Submit Response ("Notice") for corresponding Korean application number 10-2003-0025533. Items 2-4 listed on the attached PTO-1449 were first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. Item 1 is an English language counterpart of Item 2, located after receipt of the Notice. A copy of each non-US document, including the Notice, is enclosed. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.56 and MPEP § 609.

No fee is believed due. However, the Commissioner is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-0220

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 14, 2005.

Susan E. Freedman

Date of Signature: September 14, 2005

